

**PATENT NUMBER and  
ISSUE DATE**

**U.S. UTILITY Patent Application**

APPL NUM 10058946	FILING DATE 01/30/2002	CLASS 257	SUBCLASS 510	GAU 2811	EXAMINER lm
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**\*\*APPLICANTS:** Goda Akira; Noguchi Mitsuhiro; Hazama Hiroaki;

**\*\*CONTINUING DATA VERIFIED:**

**\*\* FOREIGN APPLICATIONS VERIFIED:**

JAPAN 2001-029174 02/06/2001

JAPAN 2001-317620 10/16/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

218447US2TTC

**TITLE :** Semiconductor device and method of fabricating the same

U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)

**NOTICE OF ALLOWANCE MAILED**

Assistant Examiner

**CLAIMS ALLOWED**

Total Claims

Print Claim for  
O.G.

**ISSUE FEE**

Amount Due

Date Paid

**DRAWING**

Sheets Drwg.

Figs. Drwg.

Print Fig.

Primary Examiner

**PREPARED FOR ISSUE**

Application Examiner



**TERMINAL**

**DISCLAIMER**

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